

Active plasma lenses at 10 GeV

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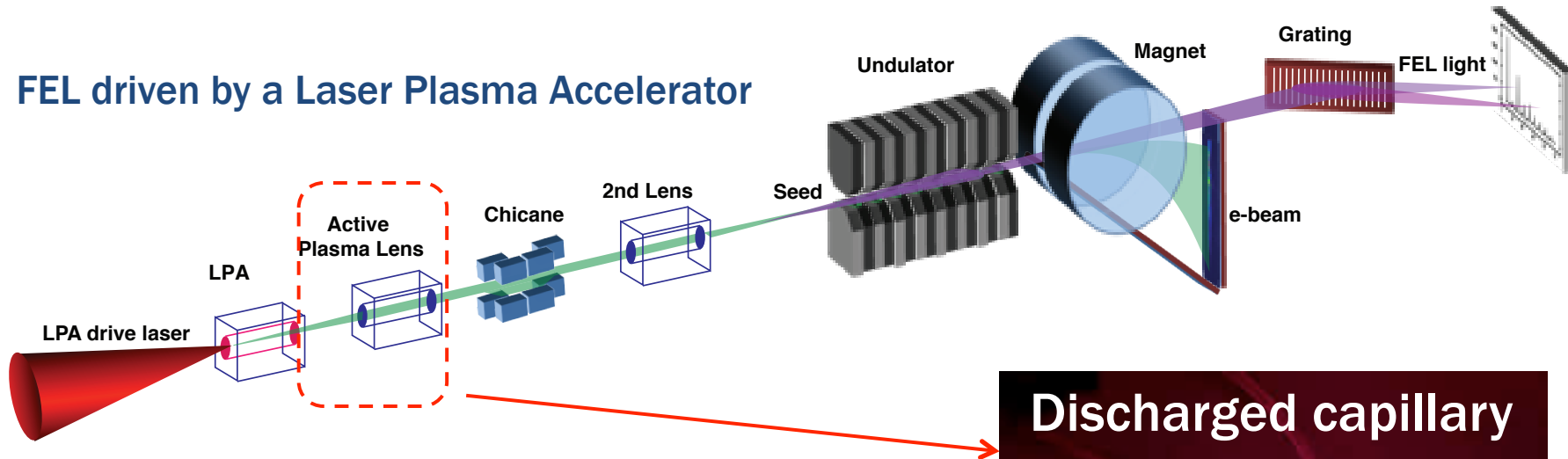
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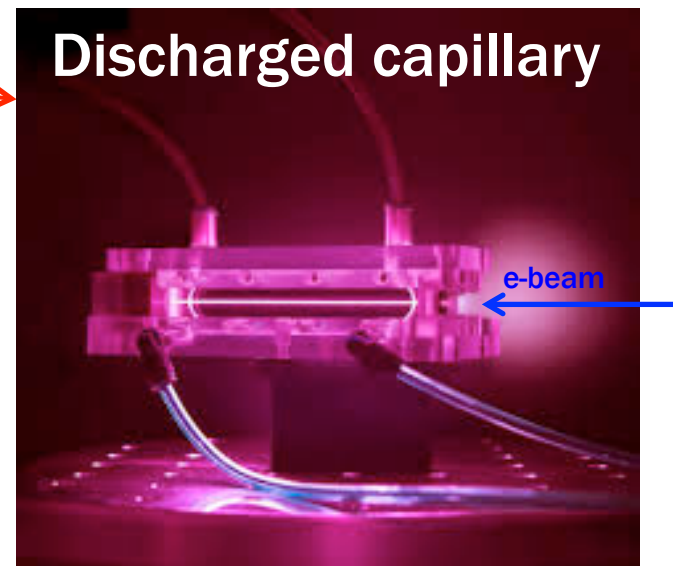
Magnetic lenses play a critical role in accelerator applications. Strength & tunability desirable.

FEL driven by a Laser Plasma Accelerator

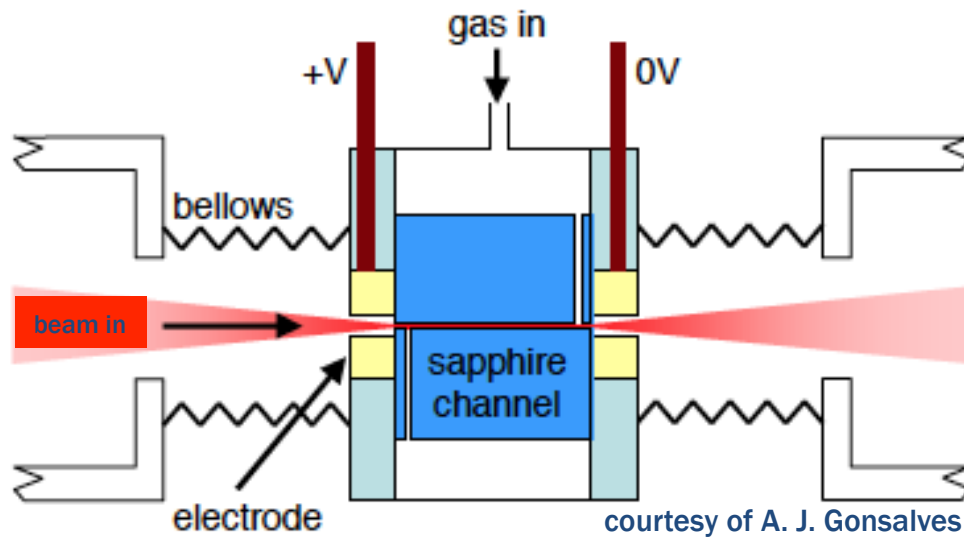


Accelerator applications → transport line

- Magnetic lens for collimation, focusing
- Focal length $\sim \gamma / (dB/dr)$
- High gradient → compact applications
- High gradient → high energy applications
- Ideal: tunable, radially symmetric
- Active Plasma Lens meets these criteria



Discharge current flowing through a capillary: linear B-gradient for uniform current distribution



Ampere's law

$$2\pi r B(r) = \mu_0 \int_0^r 2\pi r' J(r') dr'$$

$$\int_0^R 2\pi r J(r) dr = I_0$$

Uniform current

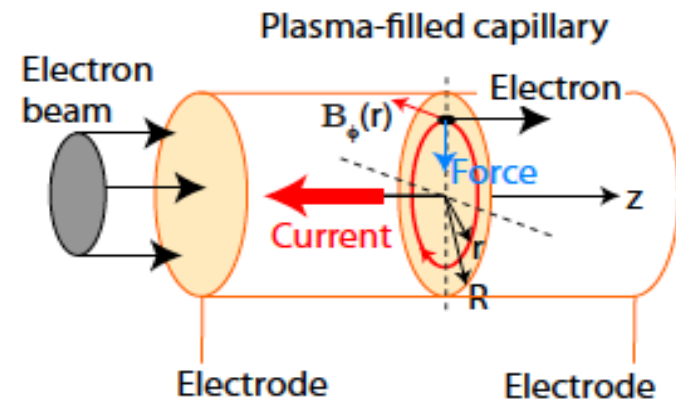
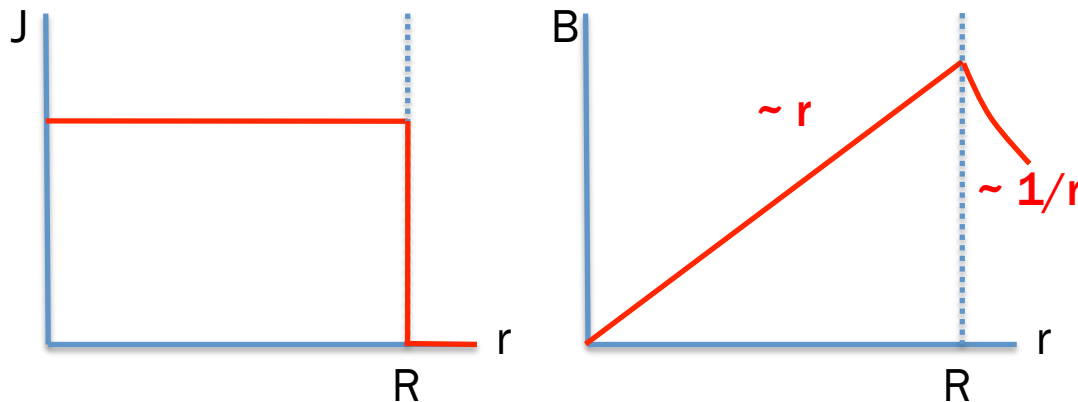
$$J(r) = J_0$$

$$J_0 = I_0 / \pi R^2$$



$$B(r) = \frac{\mu_0 I_0}{2\pi R^2} r$$

$$\frac{\partial B}{\partial r} = \frac{\mu_0 I_0}{2\pi R^2}$$



Active plasma lens an “old” concept for ion beams. Attractive due tunability, symmetry, and strength

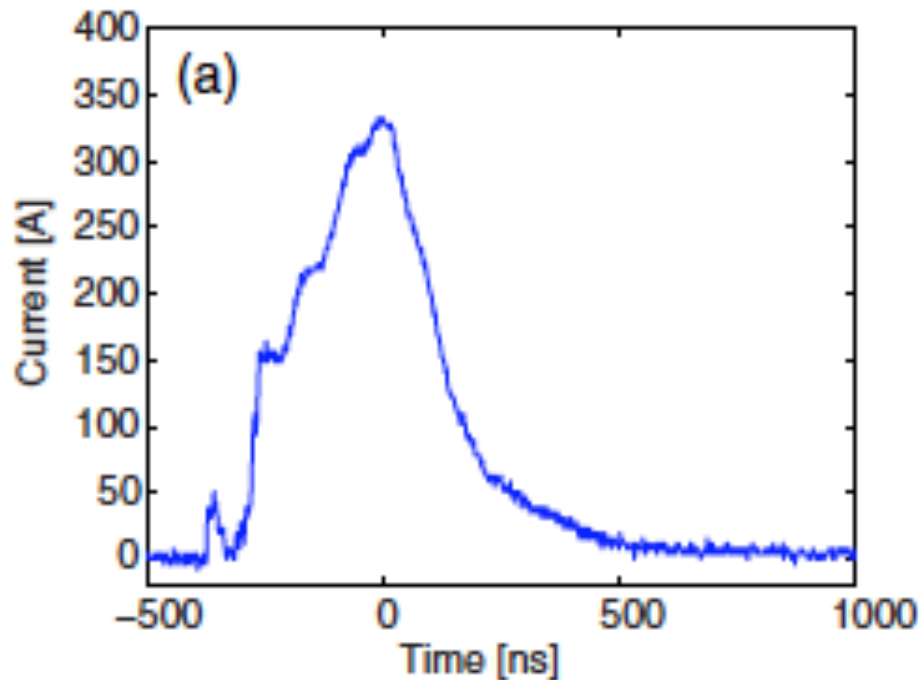
Active Plasma Lens

- Introduced 1950s (ion beams) Panofski et al. RSI 1950
- Radial symmetric focusing
- Tunable, up to ~1 kA (“active”)
- Gradients >3000 T/m

Field gradient $\frac{\partial B}{\partial r} = \frac{\mu_0 I}{2\pi R^2}$

Strength parameter $k = \frac{q}{m_0 \gamma c} \frac{\partial B}{\partial r}$

Focal length $F = 1/(kL)$



Example

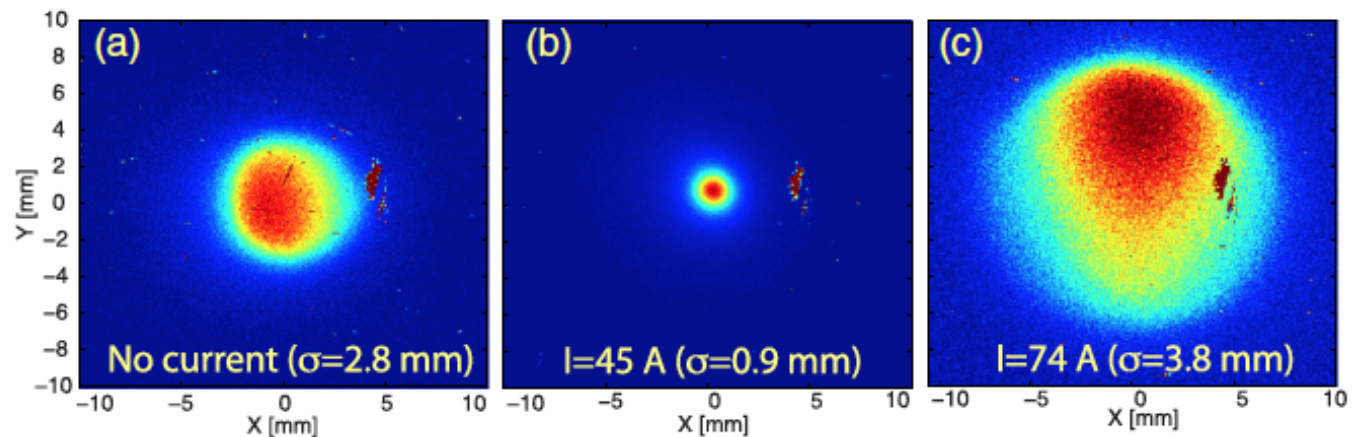
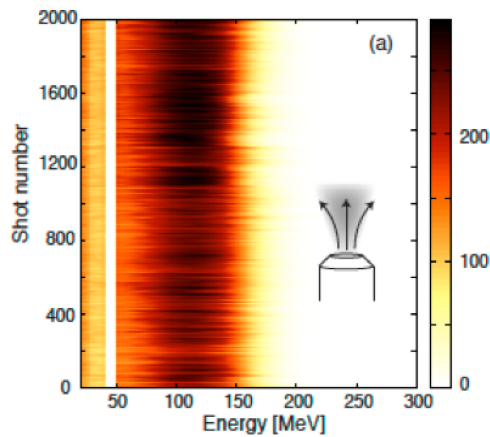
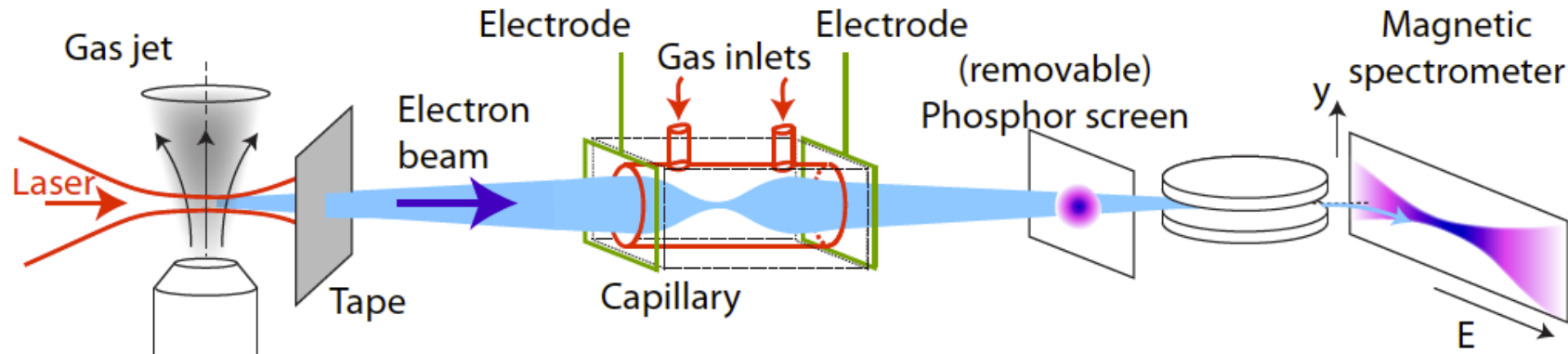
D=0.5mm, L=6cm
F=2cm @ 500 MeV
I=430 A (1400 T/m)

Example

D=0.5mm, L=6cm
F=25cm @ 10 GeV
I=695 A (2200 T/m)

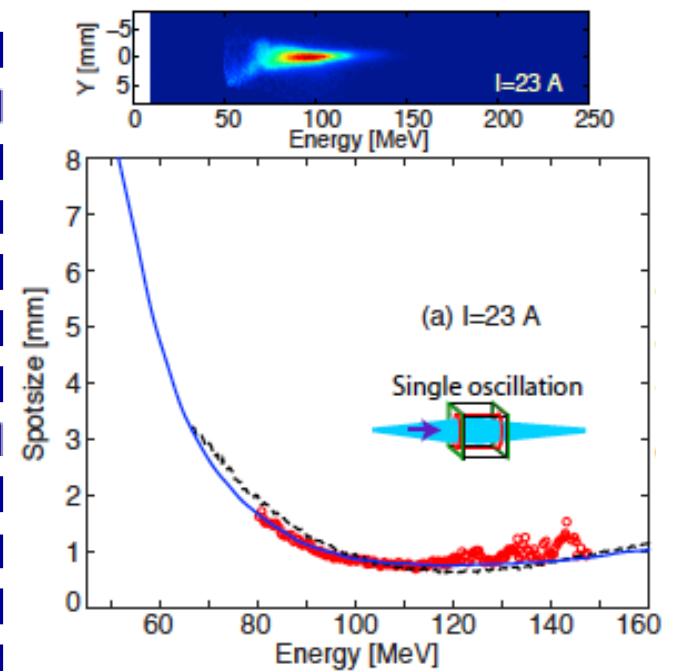
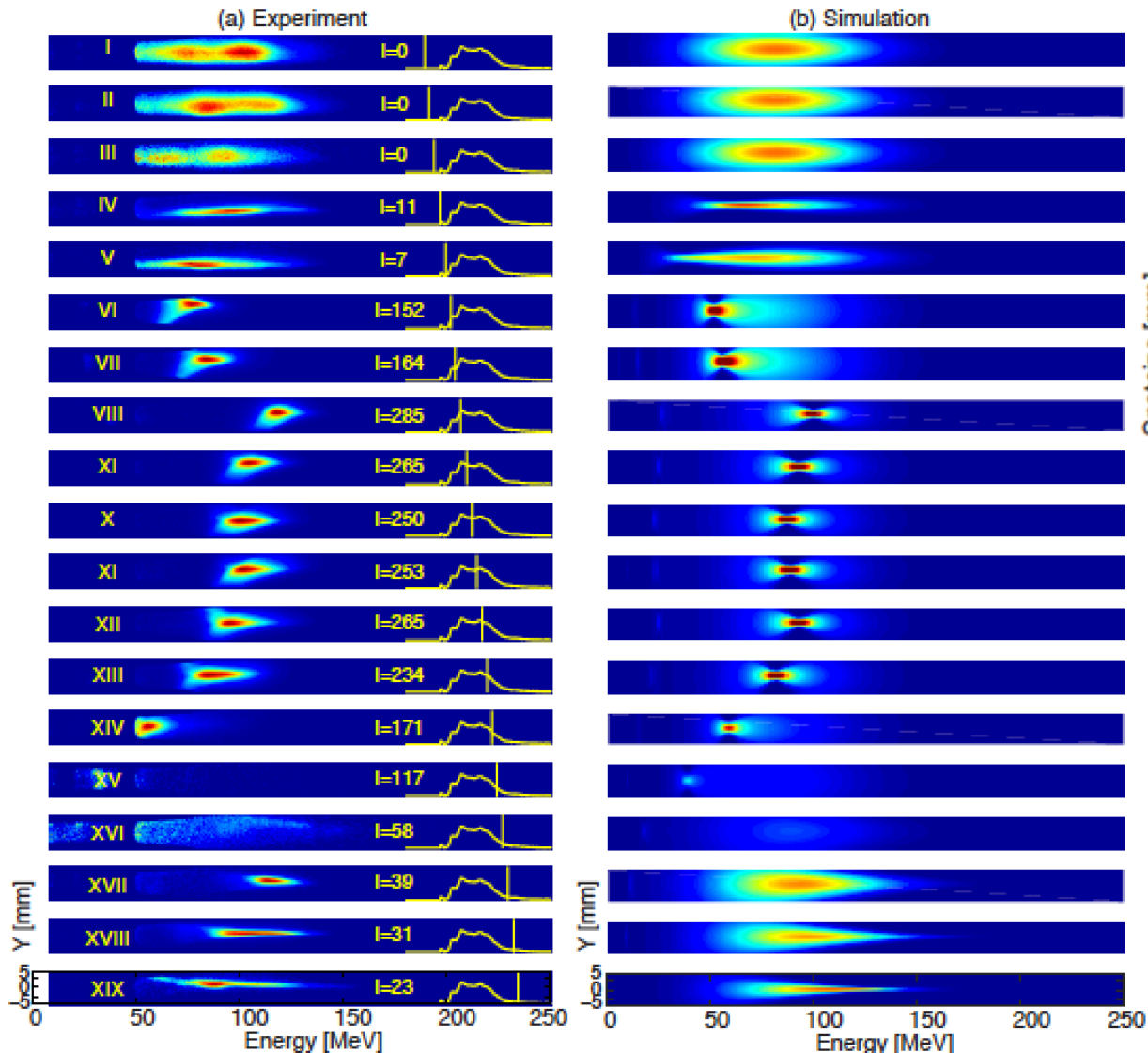
1 mrad & 25cm $\rightarrow \sigma=250 \mu\text{m}$

Experimental demonstration on Laser-Plasma Accelerated electron beams in 2015



van Tilborg *et al.* PRL 115, 184802 (2015)

Energy-dispersed beam size diagnostic reveals oscillations within plasma lens

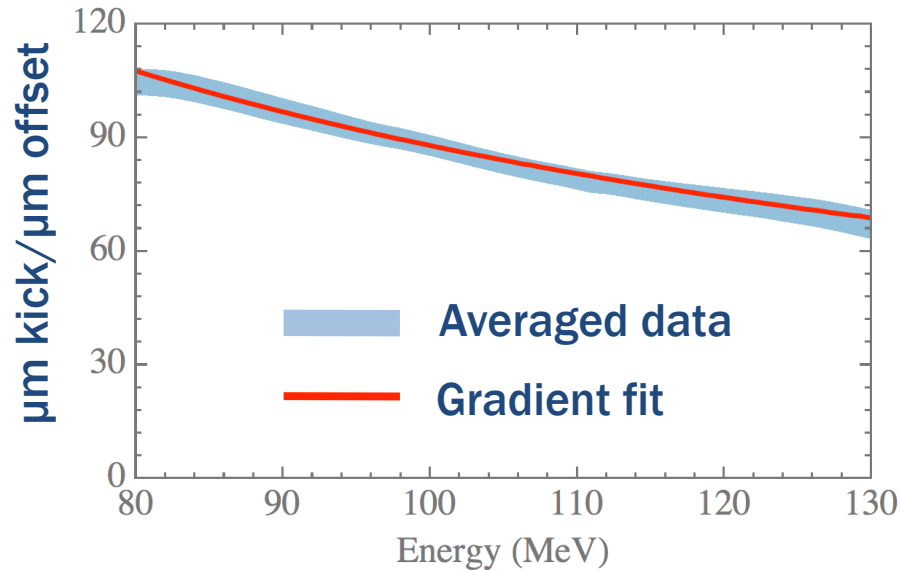


- D 0.25mm capillary, L=33mm, tape protection
- Agreement with simulation
- @300A \rightarrow 3000 T/m
- 2nd and 3rd oscillation inside lens observed

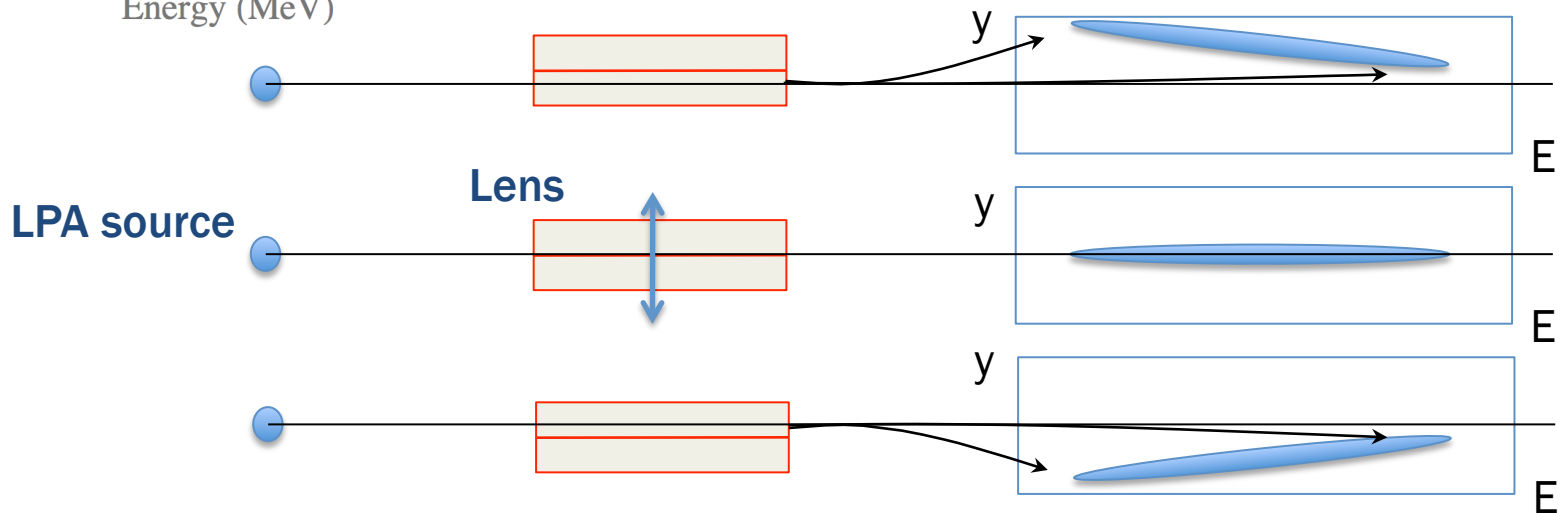
van Tilborg et al. PRL 115, 184802 (2015)

Transverse scan useful to measure focusing gradient

Model discharge current 245 A



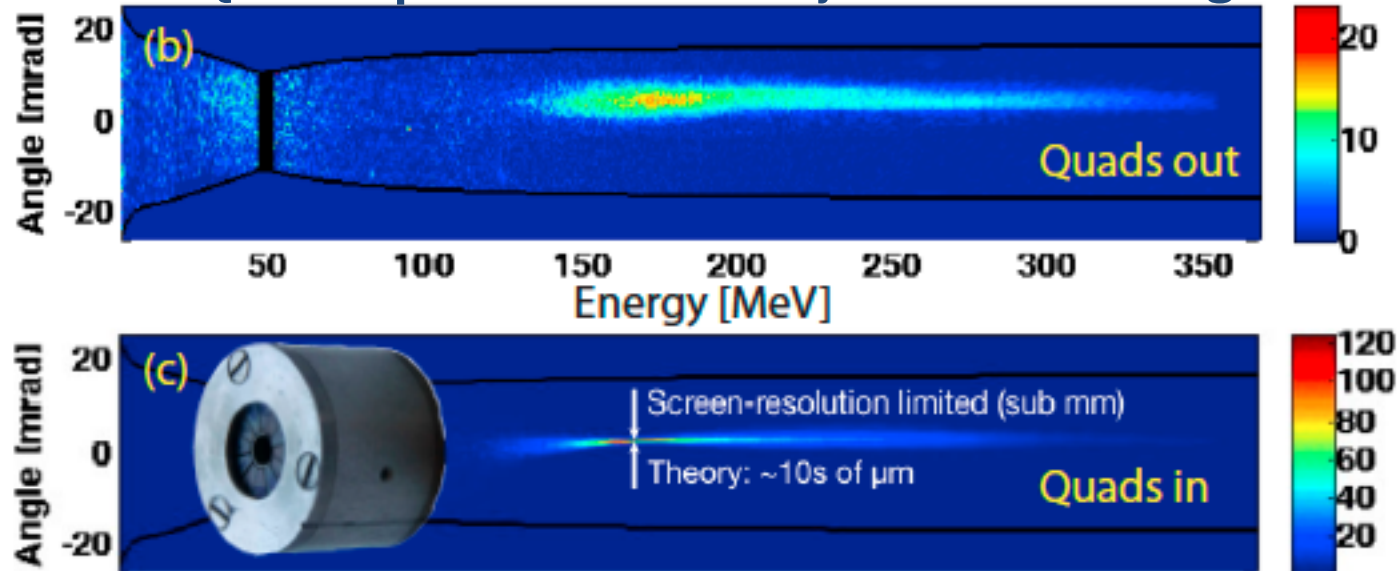
- Good technique regardless of imaging geometry
- D 0.5mm capillary, L=15mm, 30mm drift, no tape protection
- Under investigation: measured current ~360 Amps
- Cap wider (on average) by 21%?



Where active plasma lenses can provide unique solutions:

1. Ultra-relativistic e-beams

Quadrupole doublet: Asymmetric focusing



For 300 MeV e-beam

Solenoid (2 T, L=20 cm): F=500 cm

Quad doublet (500 T/m, L=3 cm): F=13 cm

Active plasma lens (2000 T/m, L=3 cm): F=1.7 cm

For 10 GeV e-beam

Quad doublet (500 T/m, L=3 cm): F=4.5 m

Active plasma lens (2000 T/m, L=6 cm): F=0.28 m

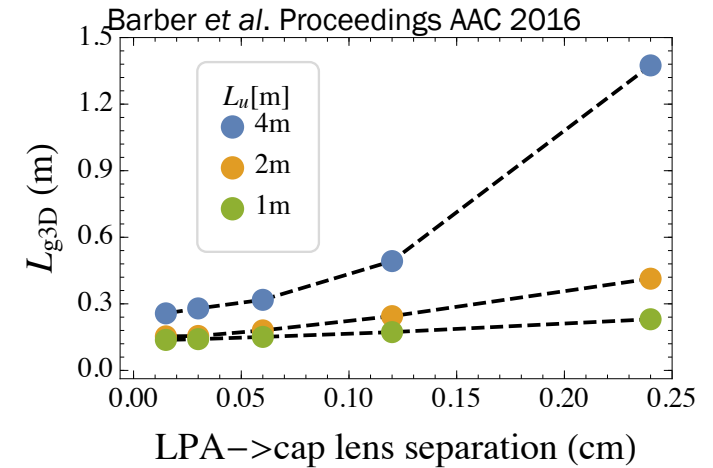
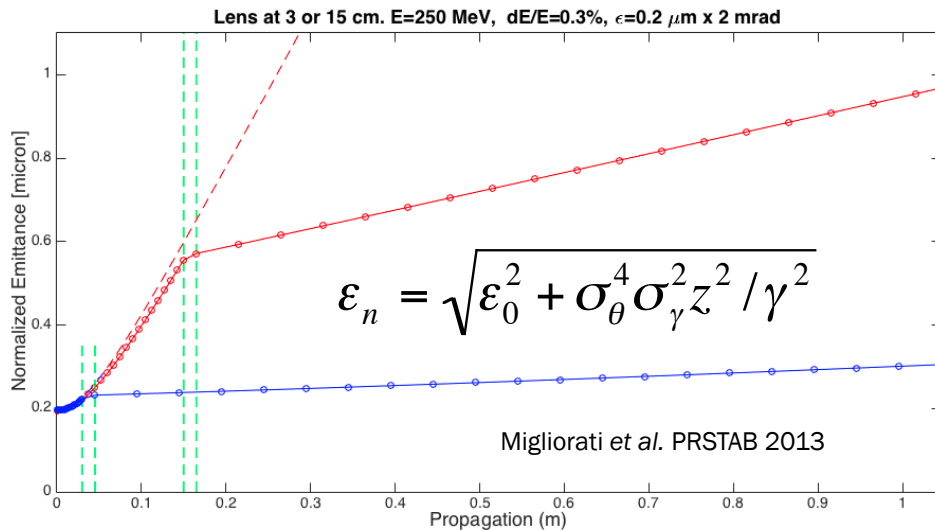
$$k = \frac{q}{m_0 \gamma c} \frac{\partial B}{\partial r}$$

(also of interest to ion beams)

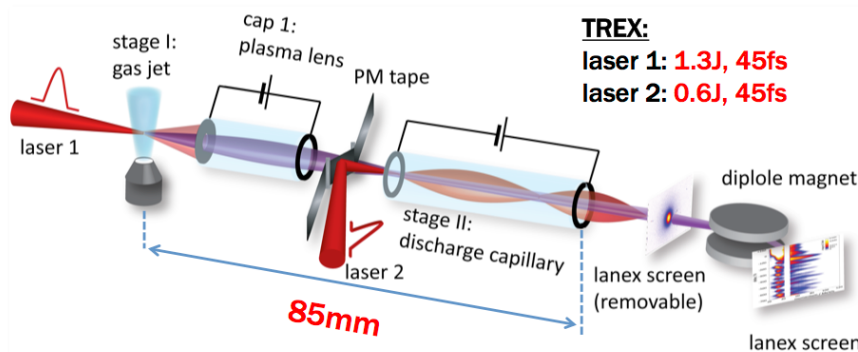
Panofski et al. RSI 1950, Boggasch et al. Proceedings EPAC '92

Where active plasma lenses can provide unique solutions:

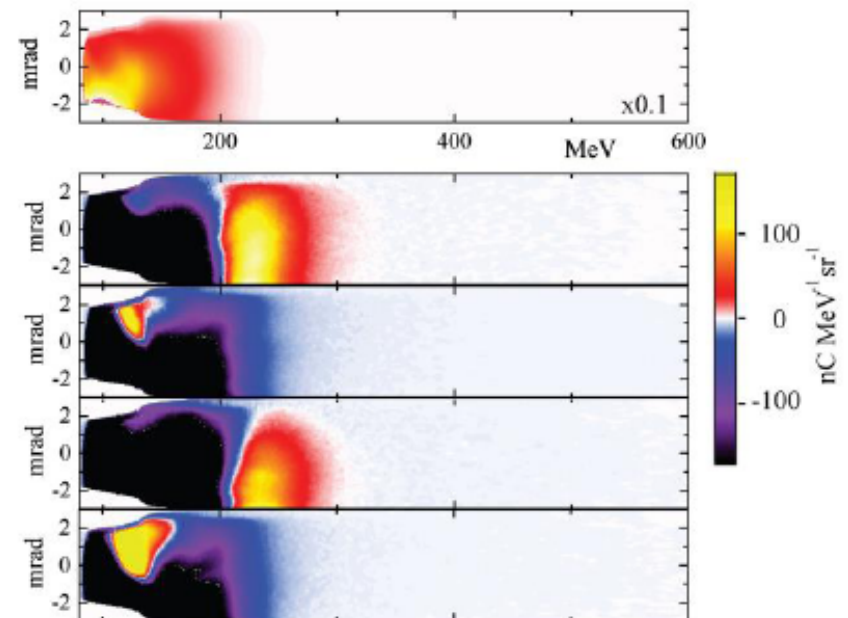
2. Rapid capture for compactness, mitigation ϵ growth



- Compact (staging)
- Quick capture \rightarrow emittance mitigation for $\Delta\gamma/\gamma \sim \%$
- Quick capture \rightarrow matching in undulator for larger $\Delta\gamma/\gamma$

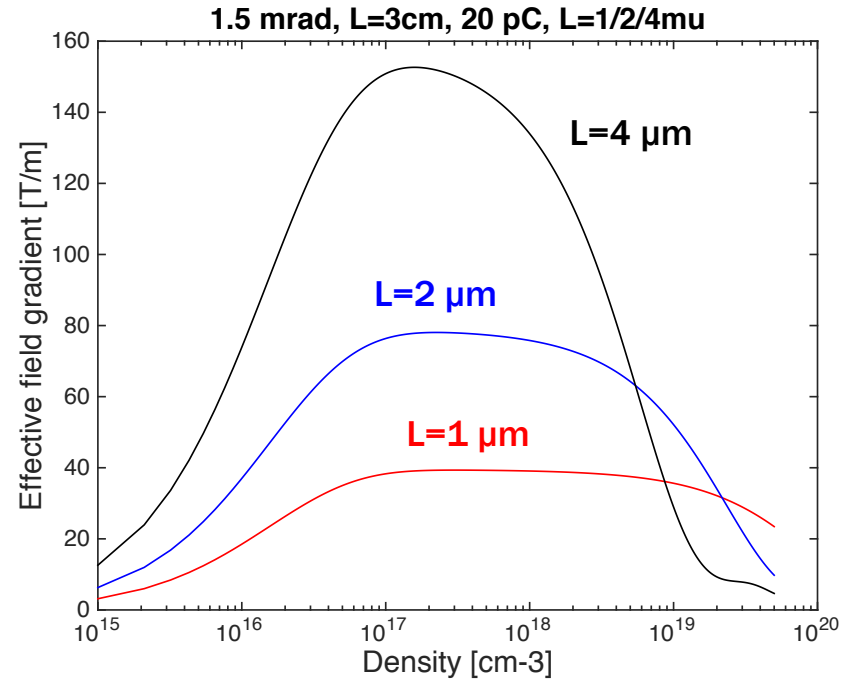
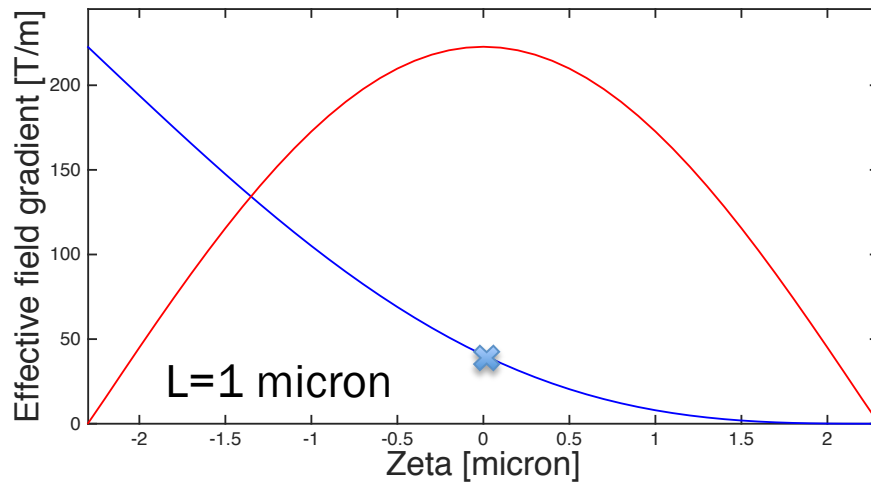
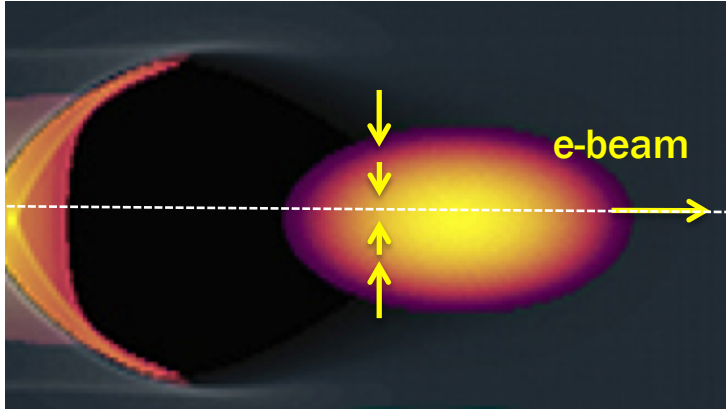


Steinke et al. Nature 2016



Possible limitation: emittance degradation from beam-driven wakefields for dense e-beams

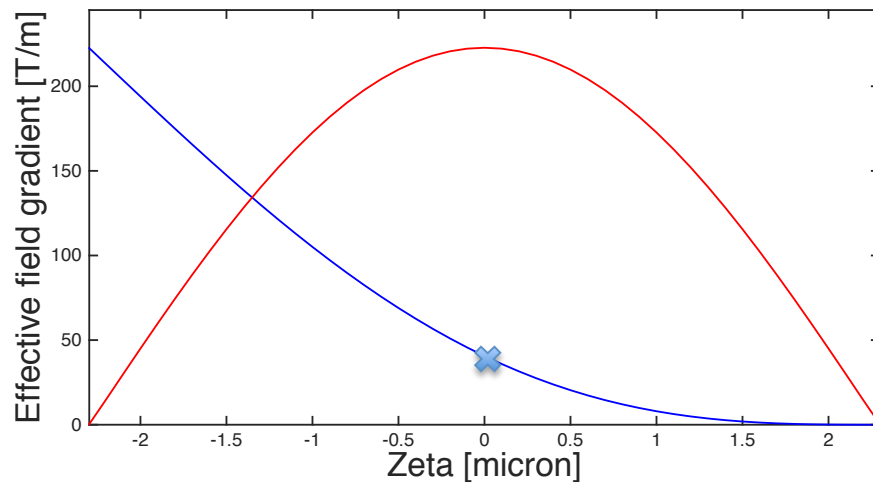
Esarey *et al.* Rev. Mod. Phys. 2009



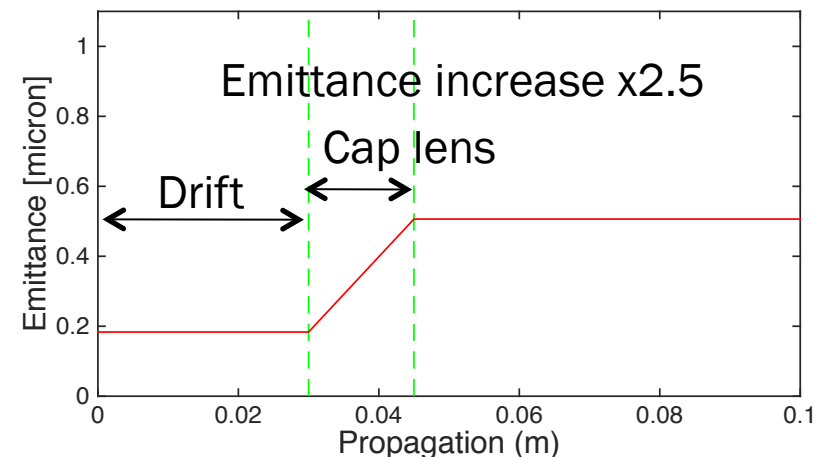
Linear regime:

$$\frac{(E_r - B_\phi)(r, \zeta)}{E_0} = \frac{\pi(k_p L)}{\pi^2 - k_p^2 L^2} \frac{n_b}{n_0} \left\{ \frac{1}{k_p} \sin \left[k_p \left(\zeta - \frac{L}{2} \right) \right] + \frac{L}{\pi} \cos \left[\frac{\pi \zeta}{L} \right] \right\} \times \left[-\frac{2r}{r_b^2} + 2k_p I_0'(k_p r) K_2(k_p r_b) \right]$$

Possible limitation: emittance degradation from beam-driven wakefields for dense e-beams



250 MeV, 0.25 micron source, 1.5 mrad
 L=2 micron, Lprop=3 cm, $\sigma=45$ micron
 $n_{\text{beam}}=1.3 \times 10^{15} \text{ cm}^{-3}$ (25pC)
 Lens=840 + 80 T/m front-end variation



To minimize wakefield effect:

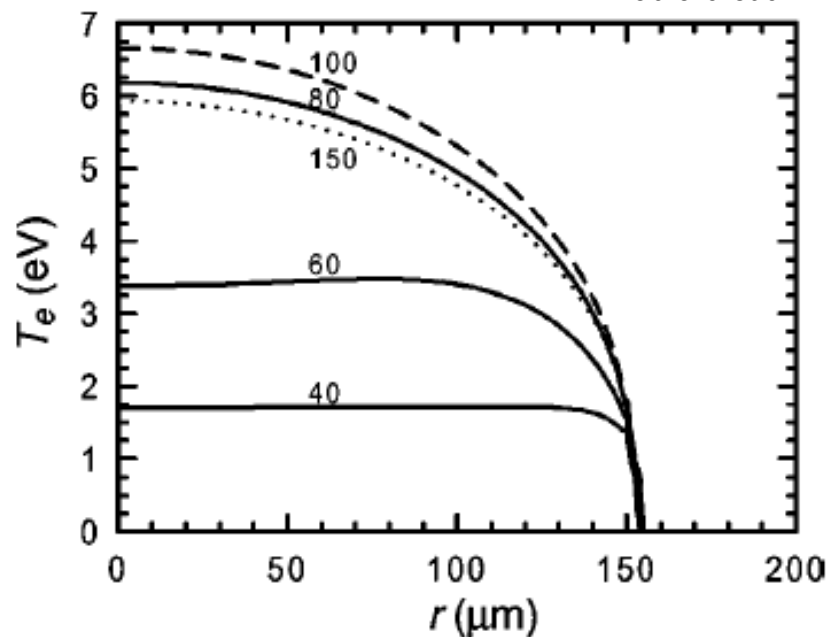
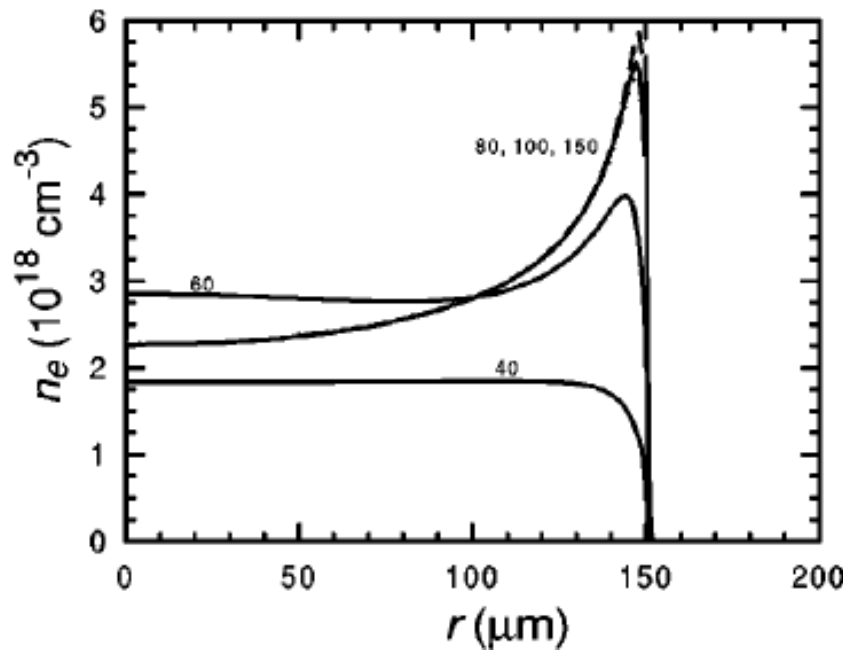
- Let e-beam divergence more
- Operate at highest current (shortest cap)
 → reduce relative effect
- Emittance degradation $\sim 1/\gamma$
- Away from resonant density (weak effect, low density most practical)
- Wakefields play role for “>20pC sub-GeV <100 μm ” beams

$$\frac{q}{m_0 \gamma c} \frac{\partial B}{\partial r} = \frac{q}{m_0 \gamma c} \left[\frac{\mu_0 I}{2\pi R^2} + \eta(\zeta - \zeta_s)^2 \right]$$

Possible limitation: emittance degradation from non-uniform current

Radial current distribution dominated by temperature
Towards peak of current pulse: more current on-axis!

Bobrova et al. PRE 2002



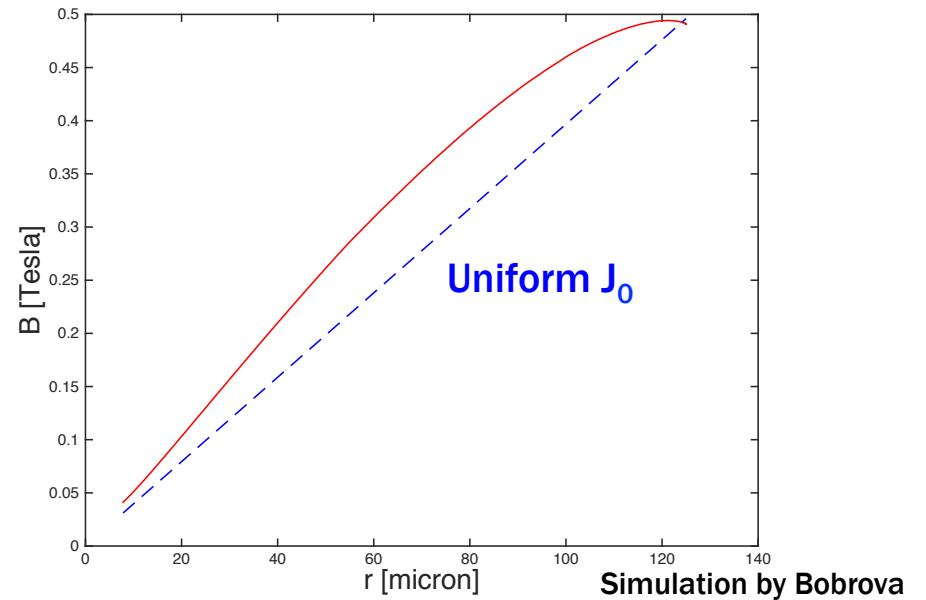
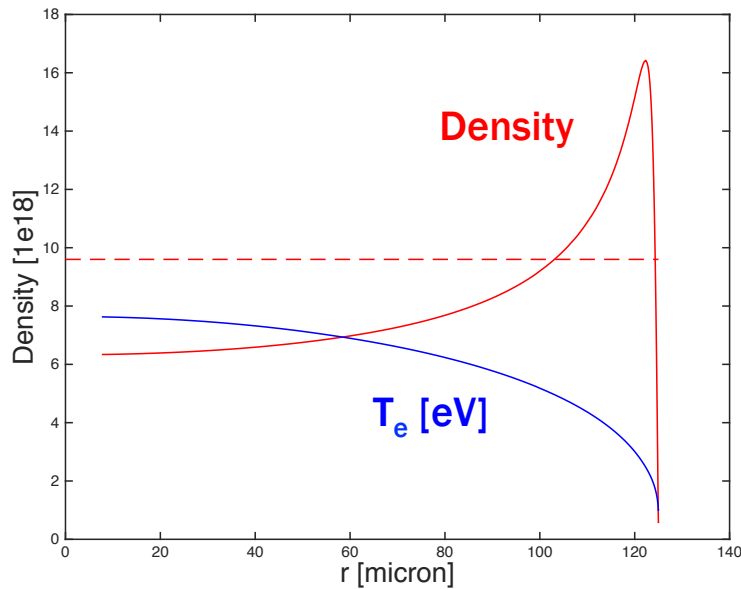
classical conductivity
(resistivity: $\eta=1/\sigma$)

$$\eta = \frac{1}{32 \pi \varepsilon_0^2} \frac{e^2 m_e^{1/2}}{(k_B T)^{3/2}} \ln \Lambda$$

$$\Lambda = n_e \lambda_D^3 = n_e \times \left(\frac{\varepsilon_0 k_B T_e}{n_e e^2} \right)^{3/2}$$

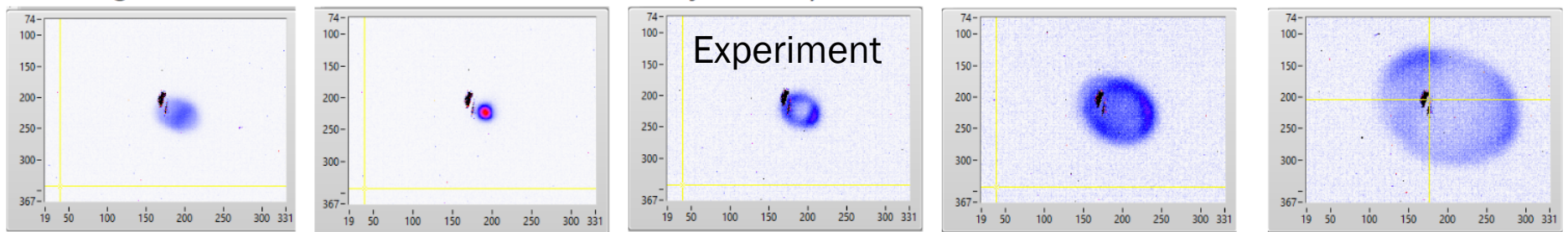
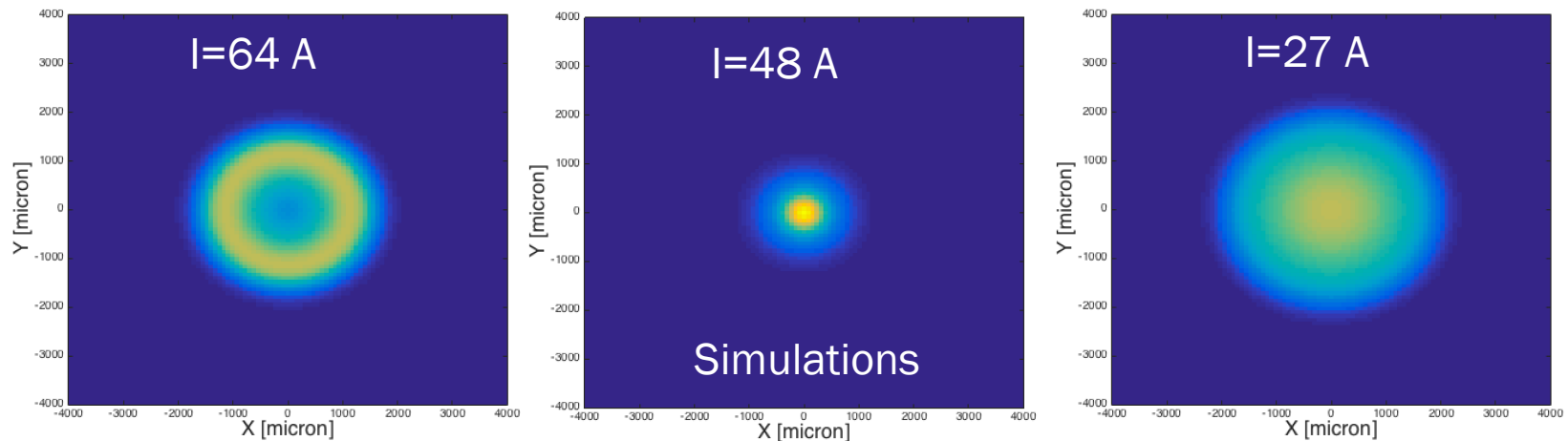
only weak dependence of n_e in $\ln \Lambda!$ \rightarrow \mathbf{J} independent of number of charge carriers

Possible limitation: emittance degradation from non-uniform current



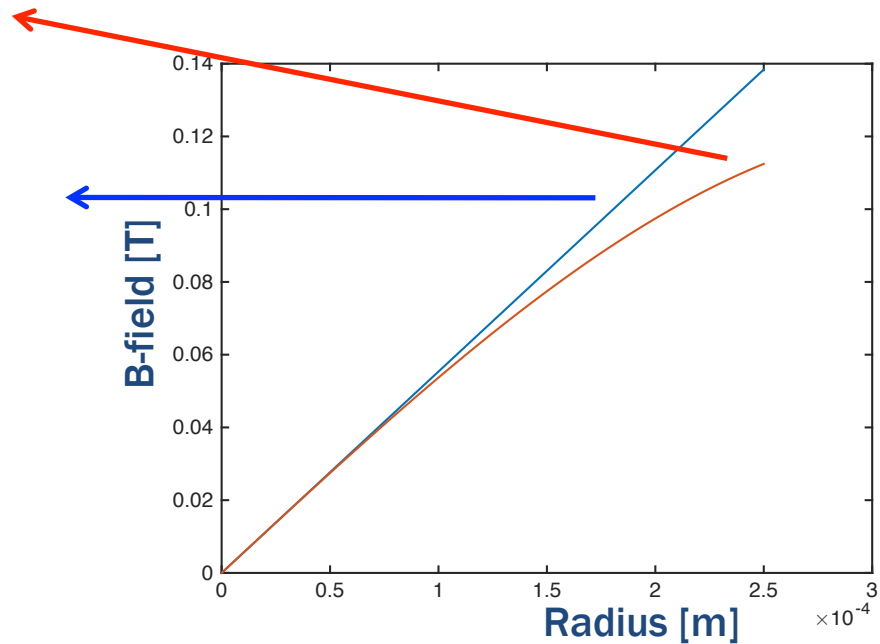
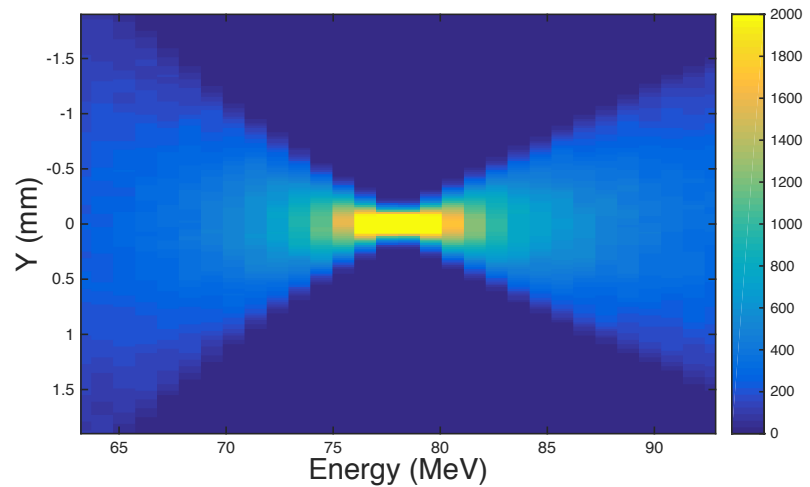
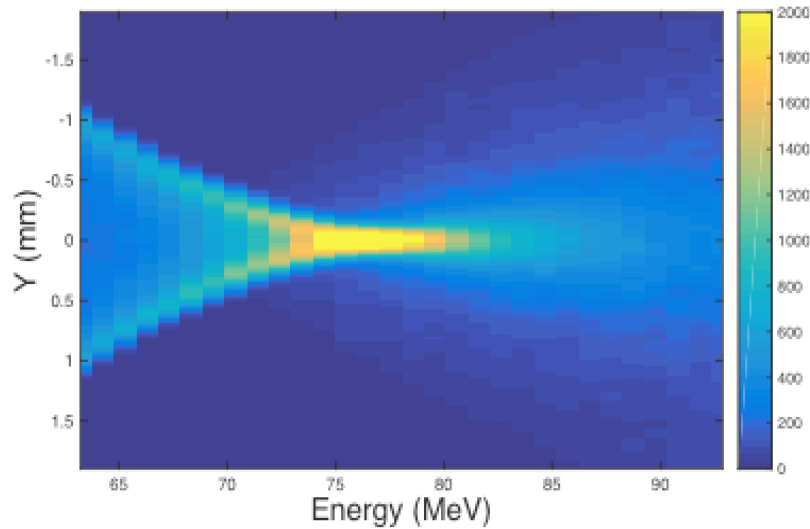
- Hotter plasma on-axis
- More current on-axis
- Stronger gradient on-axis (shorter focal length)
- Curved gradient → emittance degradation

On-axis current concentration reveals itself as donut mode when beam is over-focused

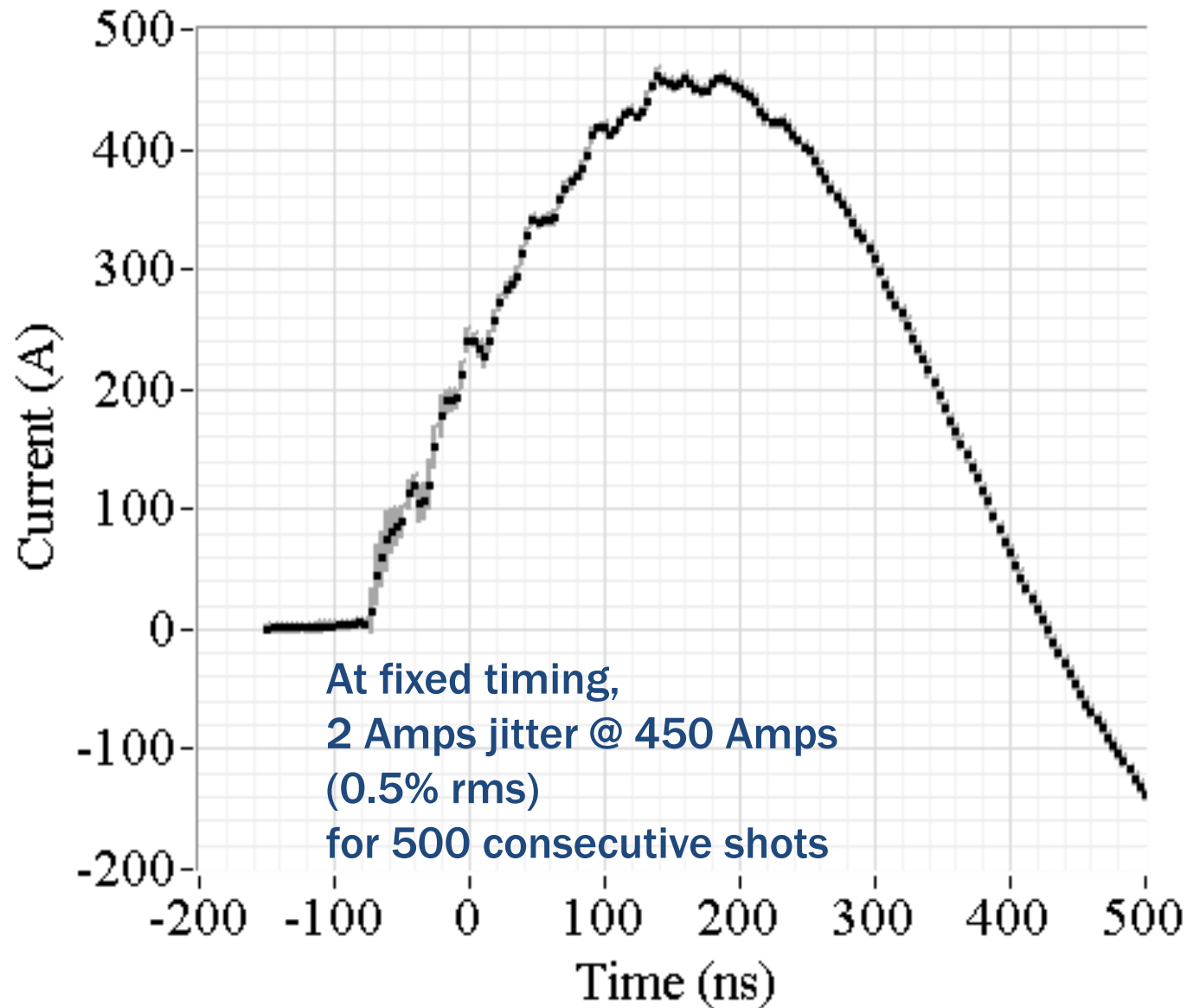


On-axis current concentration reveals itself as donut mode when beam is over-focused

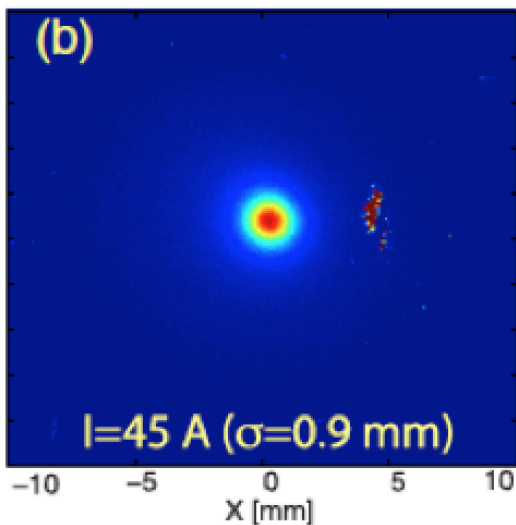
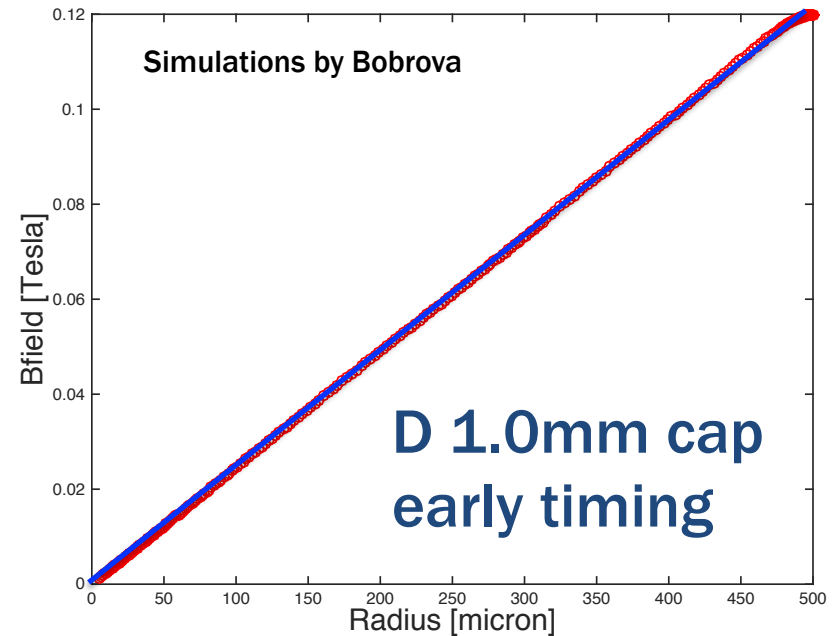
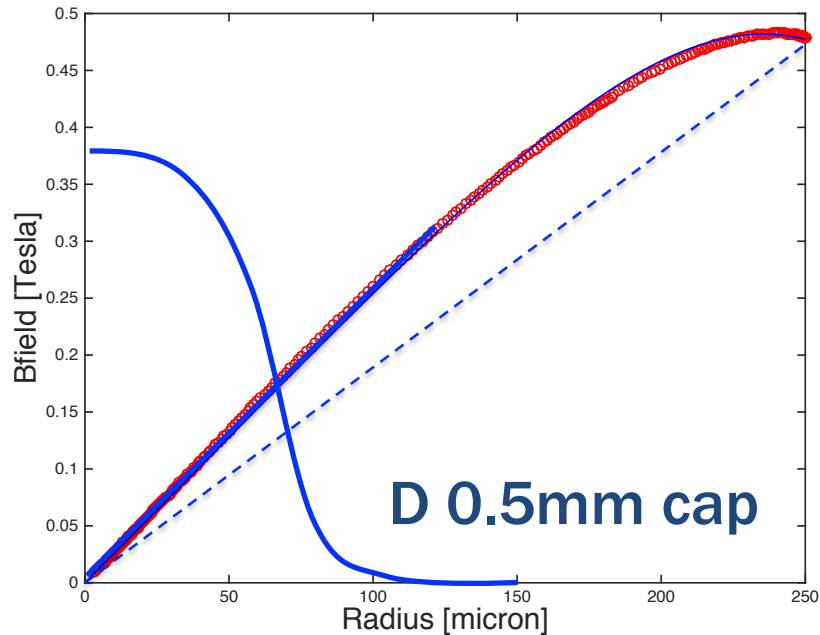
Simulation



Stability: 0.5% rms jitter in current at e-beam timing

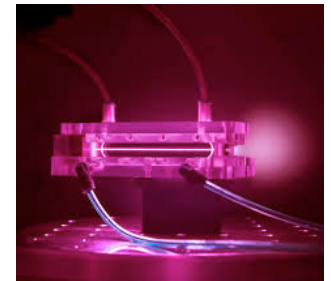


Conclusion

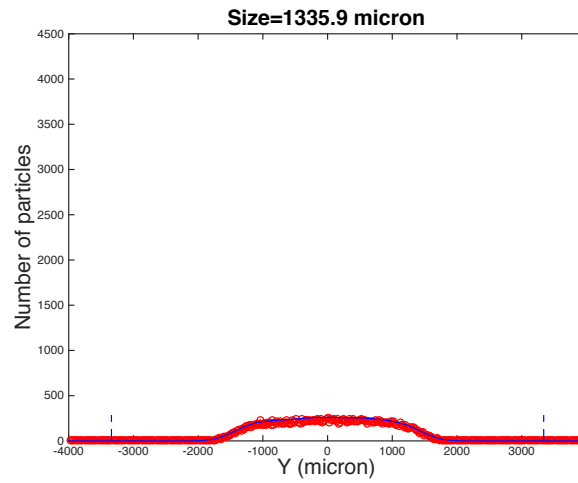
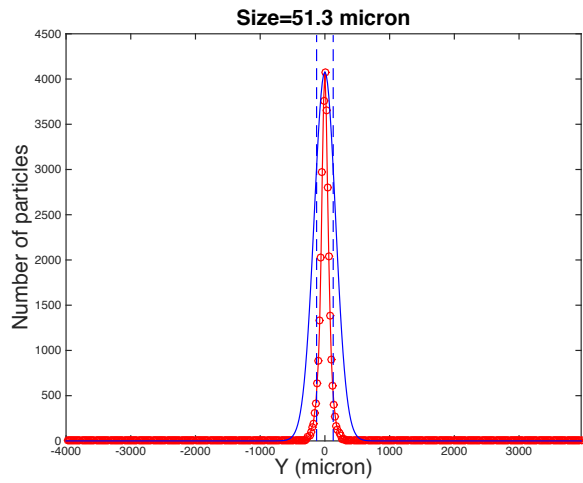


Active Plasma Lens:

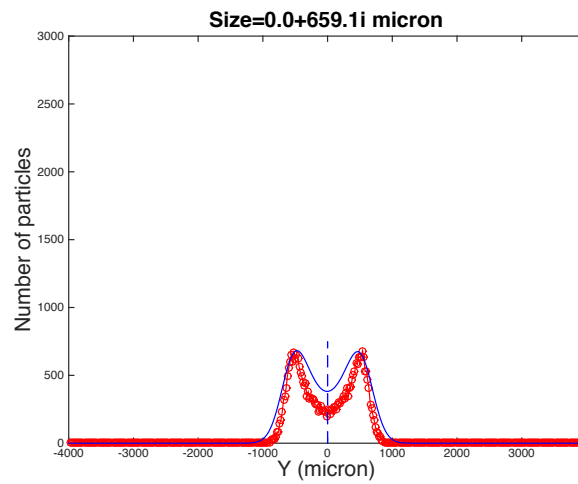
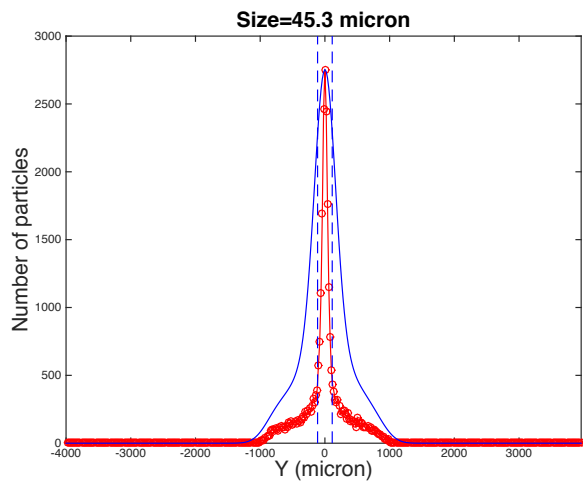
- Strong gradients observed
- Ideal for compact & GeV applications
- Understand limits wakefields and non-uniform current
- More uniform for optimized timing, pressure, diameter, beam size
- Nov 2016: DESY collaboration at Mainz accelerator



End



70 Amps, uniform



48 Amps, actual

60 MeV

40 MeV



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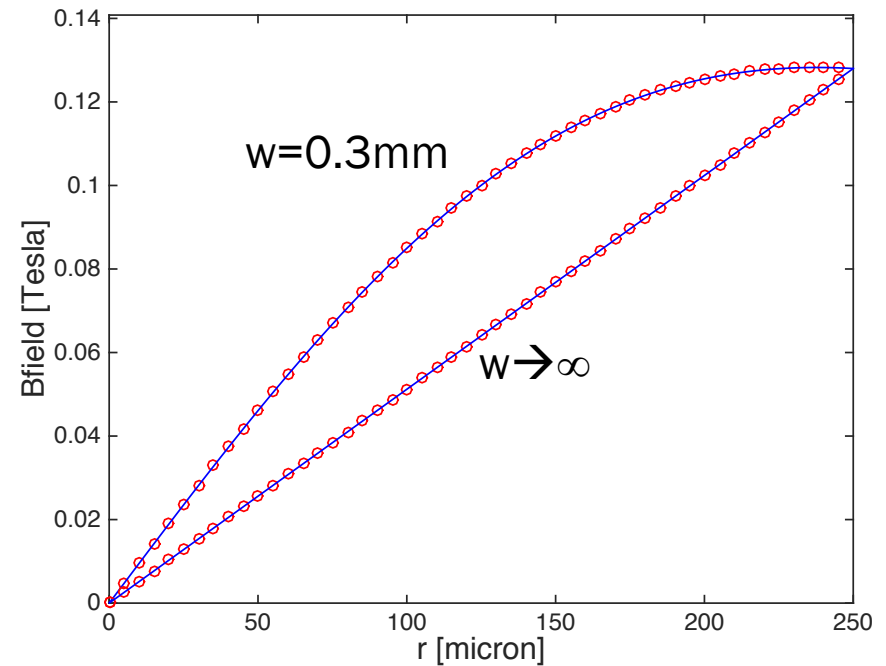
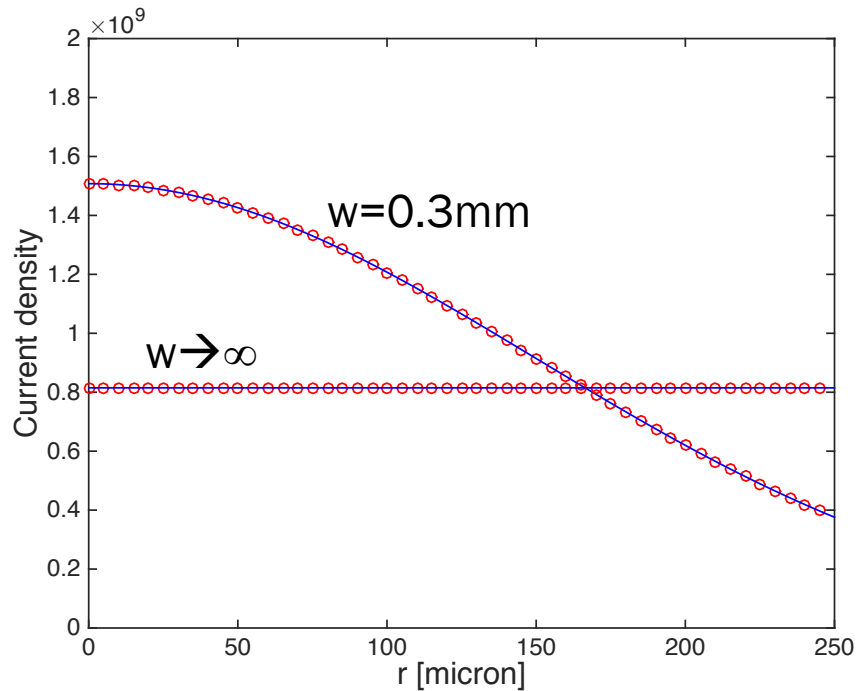


Effect of on-axis current (stronger near-axis B-field gradient)

$$J(r) = J_0 \exp(-2r^2 / w^2)$$

$$\int_0^R 2\pi J(r) r dr = I_0 \Rightarrow J_0 = \frac{2I_0}{\pi w^2 [1 - \exp(-2R^2 / w^2)]}$$

$$2\pi r B(r) = \mu_0 \int_0^r 2\pi J(r') r' dr' \Rightarrow B(r) = \frac{\mu_0 J_0 w^2}{4r} [1 - \exp(-2r^2 / w^2)]$$



Example: R=1mm, I₀ = 160 Amps



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